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1056

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10022316	FILING DATE 12/18/2001	CLASS 438	SUBCLASS	GAU 2814	EXAMINER LOUIE, W
**APPLICANTS: Tischler Michael; <i>WSL</i>					
**CONTINUING DATA VERIFIED: <i>WSL</i>					
** FOREIGN APPLICATIONS VERIFIED: <i>WSL</i>					
PG-PUB		DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>	
Foreign priority claimed		<input type="checkbox"/> yes <input checked="" type="checkbox"/> no		ATTORNEY DOCKET NO	
35 USC 119 conditions met		<input type="checkbox"/> yes <input checked="" type="checkbox"/> no		ATMI-477	
Verified and Acknowledged Examiners's initials		<i>WSL</i>			
TITLE : Wafer carrier for semiconductor process tool					
U S DEPT OF COMM /PAT & TM-PTO-436L(Rev 12-94)					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	
		Print Claim for O.G	
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs.Drwg.
		Print Fig.	
		Primary Examiner	
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	
		Applicati n Examiner	
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